503036642 10/28/2014

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT3083240

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
SHUITSU FUJII	08/07/2014
KATSUMI OI	08/07/2014

RECEIVING PARTY DATA

Name:	ADTEC PLASMA TECHNOLOGY CO., LTD.		
Street Address:	6-10, HIKINO-CHO 5-CHOME, FUKUYAMA-SHI		
City:	HIROSHIMA		
State/Country:	JAPAN		
Postal Code:	7210942		

PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	14397516	

CORRESPONDENCE DATA

Fax Number: (212)949-1690

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 212-697-3750

Email: AI@KIRSCHSTEINLAW.COM

Correspondent Name: KIRSCHSTEIN, ISRAEL, SCHIFFMILLER & PIER

Address Line 1: 425 FIFTH AVENUE

Address Line 2: 5TH FLOOR

Address Line 4: NEW YORK, NEW YORK 10016-2223

ATTORNEY DOCKET NUMBER: ADTEC-11 PCT US	
NAME OF SUBMITTER:	ALAN ISRAEL
SIGNATURE:	/Alan ISRAEL/
DATE SIGNED:	10/28/2014

Total Attachments: 1 source=asst#page1.tif

PATENT 503036642 REEL: 034047 FRAME: 0892

Docket No.

U.S. ASSIGNMENT

(Insert ASSIGNEE's	IN CONSIDERATION of the sum of One Dollar (\$1.00), and of other good and valuable consideration paid to the undersigned inventor(s) (hereinafter ASSIGNOR) by					
Name(s) Address(es))	Adtec Plasma Technology Co., Ltd. of 6-10, Hikino-cho 5-chome, Fukuyama-shi, Hiroshima 7210942 Japan					
(Title of Invention)	(hereinafter ASSIGNEE), the receipt of which is hereby acknowledged, the undersigned ASSIGNOR hereby sells, assigns and transfers to ASSIGNEE the entire and exclusive right, title and interest to the invention entitled: CAVITY RESONATOR OF MICROWAVE PLASMA GENERATING APPARATUS					
(*If the assignment is being filed after the filing of the application, this section must be completed)	for which application for Letters Patent of the United States was executed on even date herewi unless otherwise indicated below: filed on					
	and all Letters Patent of the United States to be obtained therefor on said application or continuation, divisional, substitute, reissue or reexamination thereof for the full term or terms which the same may be granted.					
	The ASSIGNOR agrees to execute all papers necessary in connection with the application and continuation, divisional, reissue or reexamination applications thereof and also to execute sepa assignments in connection with such applications as the ASSIGNEE may deem necessary expedient.					
	The ASSIGNOR agrees to execute litigation, or other legal proceeding continuation, divisional, reissue or rethereon and to cooperate with the A evidence and proceeding with such in	which may be declared conce examination thereof or Letters : SSIGNEE in every way possib	erning this application or any Patent or reissue patent issued le in obtaining and producing			
	IN WITNESS WHEREOF, the undersigned inventor(s) has (have) affixed his/her/their signature(s).					
(Signatures)	Shuiton Frijis	FUJII, Shuitsu	August 7, 2014			
	(Signature)	(Type Name)	(Date)			
	Di Katsumi	OI Votanni	August 7, 2014			
	(Signature)	OI, Katsumi (Type Name)	(Date)			
	(Signature)	(Type Name)	(Date)			
	(Signature)	(Type Name)	(Date)			
	(Signature)	(Type Name)	(Date)			
	(Signature)	(Type Name)	(Date)			
NO LEGALIZATION RI	EQUIRED		Re. 07/07			

PATENT REEL: 034047 FRAME: 0893

RECORDED: 10/28/2014